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Docket No.: M4065.0243/P243 A  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Craig A. Hickman et al.

Application No.: 10/771,291

Confirmation No.: 3240

Filed: February 5, 2004

Art Unit: 2857

For: WAFER ALIGNMENT SYSTEM

Examiner: Hal D. Wachsman

**SUPPLEMENTAL AMENDMENT**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated November 8, 2004, please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.